EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	"10554087"	USPAT	AND	ON	2008/04/23 11:26
L2	966	(semiconductor with manufactur$4) & (particle with detect $4) & storage & cause & surface	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/04/23 11:29
L3	180	(semiconductor with manufactur$4) & (particle with detect $4) & storage & cause & surface & binar$4	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/04/23 11:30
L4	282	"250"/$.ccls. & (semiconductor with manufactur$4) & (particle with detect $4) & storage & cause & surface	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/04/23 11:33
L5	0	"250"/341.8 & (semiconductor with manufactur$4) & (particle with detect $4) & storage & cause & surface	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/04/23 11:34
L6	26	"250"/559.41 & (semiconductor with manufactur$4) & (particle with detect $4) & storage & cause & surface	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/04/23 11:35
L7	199	"356"/$.ccls. & (semiconductor with manufactur$4) & (particle with detect $4) & storage & cause & surface	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/04/23 11:36
L8	57	"356"/237.4 & (semiconductor with manufactur$4) & (particle with detect $4) & storage & cause & surface	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/04/23 11:37

L9	57	"382"/$.ccls. & (semiconductor with manufactur$4) & (particle with detect $4) & storage & cause & surface	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/04/23 11:38
L10	56	"382"/145 & (semiconductor with manufactur$4) & (particle with detect $4) & storage & cause & surface	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/04/23 11:38
L11	60	"702"/$.ccls. & (semiconductor with manufactur$4) & (particle with detect $4) & storage & cause & surface	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/04/23 11:38
L12	9	"702"/81 & (semiconductor with manufactur$4) & (particle with detect $4) & storage & cause & surface	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/04/23 11:40
L13	2	"702"/33 & (semiconductor with manufactur$4) & (particle with detect $4) & storage & cause & surface	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/04/23 11:40
L14	4	"702"/167 & (semiconductor with manufactur$4) & (particle with detect $4) & storage & cause & surface	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/04/23 11:41
L15	4	"702"/108 & (semiconductor with manufactur$4) & (particle with detect $4) & storage & cause & surface	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/04/23 11:41
L16	14	"702"/117 & (semiconductor with manufactur$4) & (particle with detect $4) & storage & cause & surface	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/04/23 11:41

L17	1	"702"/128 & (semiconductor with manufactur$4) & (particle with detect $4) & storage & cause & surface	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/04/23 11:41
L18	12	"702"/155 & (semiconductor with manufactur$4) & (particle with detect $4) & storage & cause & surface	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/04/23 11:41
L19	4	"702"/188 & (semiconductor with manufactur$4) & (particle with detect $4) & storage & cause & surface	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/04/23 11:41

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